IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Gordon M. Grivna

Concurrently Herewith FILED:

FOR: SEMICONDUCTOR DEVICE HAVING REDUCED

CAPACITANCE TO SUBSTRATE AND METHOD

1/5/2004 Date:

DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56

Honorable Assistant Commissioner for Patents Washington, D.C. 20231

SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,

Gordon M. Grivna et al

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Phone: 602-244-4885 602-244 3169 Fax:

Customer #: 27255

Form PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION

PPLICANT'S INFORMATION DISCLOSURE STATEMENT

(Use Several Sheets if Necessary)

ATTY. DOCKET NO.	SERIAL NO.
ONS00470	
APPLICANT	
Gordon M. Grivna	
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U.S. PATENT DOCUMENTS

Examination Initial	er	Docum	nent	Nu	mbe	r				Date	Name	Class	Sub- Class	Filing date (If approp rirate)
	AA		6	6	6	1	0	6	8	12/9/2003	Durham et al	H01L	21/20	
	AB		5	7	4	2	0	9	1	4/21/1998	Hebert	H01L	29/76	
.,	AC		5	8	4	4	2	9	9	12/1/1998	Merrill et al.	H01L	29/00	
	AD		6	1	8	0	9	9	5	1/30/2001	Hebert	H01L	29/00	
7	AE		6	2	2	1	7	2	7	4/24/2001	Chan et al.	H01L	21/20	
	AF		6	3	0	7	2	4	7	10/23/2001	Davies	H01L	29/00	
	AG	2003	0	1	4	6	4	9	0	8/7/2003	Averett et al.	H01L	29/00	
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FOREIGN PATENT DOCUMENTS

Examiner Initial		Document #						Dat	e	Country	Class/s	ubclass	Trans Yes	lation - No	
	AN														
	AO														
	AP														
	AQ														
	AR														

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.